

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Shigeo IRIE)
Japanese Priority Application No. 2000-192459) Attn: Applications
Japanese Priority Date: June 27, 2000) Branch
For: PATTERN FORMING METHOD AND)
APPARATUS FOR FABRICATING)
SEMICONDUCTOR DEVICE) Date: June 26, 2001



#2
D.G.
9-21-01

INFORMATION DISCLOSURE STATEMENT

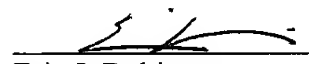
Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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